

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: NISHIO  
Application No.: 10/583,348  
Filed: 4/5/2007  
Title: METHOD FOR REMOVING DEPOSIT FROM SUBSTRATE AND METHOD  
FOR DRYING SUBSTRATE, AS WELL AS APPARATUS FOR REMOVING  
DEPOSIT FROM SUBSTRATE AND APPARATUS FOR DRYING  
SUBSTRATE USING THESE METHODS  
Group AU: 1714  
Examiner: Campbell, Natasha N.  
Confirm. No.: 9732

**AMENDMENT**

**Mail Stop: AMEND – NO FEE**  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, Virginia 22313-1450

November 12, 2010

SIR:

In response to the Office Action mailed August 11, 2010, please amend the above-identified application as listed in the following, and as set forth on the following pages:

AMENDMENTS TO THE DRAWINGS;

AMENDMENTS TO THE SPECIFICATION;

AMENDMENTS TO THE CLAIMS; and

REMARKS are included following the amendments.

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